



	<u></u>				Sheet _	1 of <u>1</u>	
Form PTO-1449 U.S. Department (Rev. 8-83) Patent and Trad			Att rney Docket N . 0756-2011		Serial N . N t Y t Assigned		
INF	ORMATION DISCLOSURE STA	TEMENT	Applicant: Shunpei Y	'AMAZAKI et a	al.		
(Use several sheets if necessary)			Filing Date: July 28, 1999		Gr up: N t Yet Assigned		
	τ	J.S. PATEN	T DOCUMENTS				
Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date appropriate)	(if
7							
<u>-</u> :					1		
			· · · · · · · · · · · · · · · · · · ·				
	FO	REIGN PAT	ENT DOCUMENTS		· ·	T	
	Document Number	Date	Country	Class	Subclass	Translation Yes No	
19	7-162004	6/23/95	Japan			Abstract	ļ
1 /	OTHER DOCUMENTS	S (Including A	uthor, Title, Date, Pe	ertinent Page	s, Etc.)		
1	"Recent Progress of Low To Electronic Display Forum, S	emperature po 99, pp. 4-31 to	oly-Si Technology" 4-38 (Full translatio	Hiroshi TS on attached	UTSU, Proce	edings of	
	"Uniformity Improvement of Excimer Laser Crystallized Poly-Si Thin Film Transistors" Sera et al., AM-LCD '96/IDW '96, 1996, pp. 85-88.						
•							

*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Examiner

Date Considered